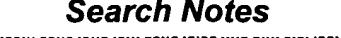


Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination	
	09/909,364	TAN ET AL.	
	Examiner Shi K. Li	Art Unit 2633	

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner